Examiner: Chen, Kin Chan

Art Unit: 1765



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Anne E. Miller et al.

Serial No.: 09/715,282

Filed: November 16, 2000

For: SLURRY AND METHOD FOR CHEMICAL MECHANICAL POLISHING OF COPPER Mail Stop ISSUE FEE Commissioner for Patents P.O. Box 1450

SUBMISSION OF FORMAL DRAWINGS

Dear Sir:

Enclosed herewith for submission in the United States patent application referenced above are three (3) sheets of formal drawings.

If there are any further charges please charge them to Deposit Account No. <u>02-2666</u>.

Respectfully submitted, BLAKELY, SOKOLOFF, TAYLOR & ZAFMAN

Date: $\sqrt{27}$, 2004

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FIRST CLASS CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to: Mail Stop ISSUE FEE, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450 on <u>January 27, 2004</u>.

Claire Wallters		
Name of Person Mailing Correspondence		
Ciaire Walter	1/27/2004	
Signature	Date	